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## IMPORTANT NOTICE TELECOPY/FACSIMILE COVER LETTER

TO: U.S. Patent & Trademark Office  
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DATE: February 3, 2004

FROM: Eugene J. Bernard, Esq.  
Hogan & Hartson LLP

TIME: \_\_\_\_\_

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CLIENT NUMBER: 81848.0016.001

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Serial No. 09/546,174  
Application of: Chih-Chien LIU, et al.  
Filed: April 11, 2000  
Art Unit: 1711  
Examiner: R.A. SERGENT  
Attorney Docket No. UMC-96-279 CON  
For: HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS  
Confirmation No.: 4793  
Customer No.: 25235

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office

1. Amendment and Response to the Office Action Mailed December 23, 2003; and
2. Amendment Fee Transmittal Form (2 copies)

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Attorney Docket No. UMC-96-279 CON  
Client Matter No. 81848.0016.001

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No. 09/546,174 Application of: LIU, Chih-Chien <i>et al</i> Filed: April 11, 2000 Art Unit: 1711 Examiner: SERGENT, R.A. Attorney Docket No. UMC-96-279 CON For: HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS	Confirmation No.: 4793 Customer No.: <b>25235</b>
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**AMENDMENT AND RESPONSE TO THE OFFICE ACTION**  
**MAILED DECEMBER 23, 2003**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

An Office Action was mailed in the above case December 23, 2003.

Please reconsider the case in light of the amendment and remarks that follow.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 9 of this paper.